

Comparison of screening current simulation modellings of REBCO pancake coils

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- The screening current is troublesome:
	- \checkmark Undesired field is generated.
	- \checkmark Overstress is generated.
- A few screening current model have been proposed:

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- \checkmark Axisymmetric FEM
- \checkmark FEM + thin film approximation
- \checkmark Simple equivalent circuit
- \checkmark Complicated network equivalent circuit (newly developed)

Overview

Overview

Screening current REBCO coil

Overview

Important!

 \triangleright Why is the detailed screening current distribution needed?

 \checkmark Mostly, the magnet center is sufficiently far from coils having screening current. Hence, if the net amount of screening current was right, we can obtain the accurate screening-current-induced field at magnet center.

All the simulation methods can compute the magnetic field at magnet center with enough accuracy.

 \checkmark In recent years, we have an attention to the coil stress. A large stress deteriorates the critical current or destroys the REBCO tape mechanically, sometimes plastic deformation occurs. Therefore, to know the detailed stress, the accurate current distribution is desired.

I. Axisymmetric FEM

Equations

[∂]*^I* ⁼ [∂]*^R*

∂*V*

[∂]*^I* ⁼ *^R* ¹

Ic

$$
\frac{\partial}{\partial z} \left(\frac{1}{\mu} \frac{\partial A}{\partial z} \right) + \frac{\partial}{\partial r} \left\{ \frac{1}{r\mu} \frac{\partial}{\partial r} (rA) \right\} - \left(\sigma \frac{\partial A}{\partial t} + J_{op} \right) = 0
$$

lE^c

⁼ *lE^c I*2

lE^c

Features

- \triangleright Easy to solve, but hard to generate a mesh
- \triangleright Need a special technique to flow the operating current. b flow the operating current. **Example 15 K**
- \triangleright Not exist the axial current
- \triangleright Impossible to model the pancake-winding structure noguchi@ssi.ist.hokudai.ac.jp).

explained below.

A. Simple model

resistance, the contact resistance, and the operating current, respectively. The coil inductance *L* is easily computed by a method in [9], and the turn-to-turn contact resistance *R*ct is

(8)

I. Axisymmetric FEM T axis method is based on $2D$ axis ymmetric finite element T axis ymmetric finite element T $\frac{1.753911111666161E}{2}$

solution, though mesh-making is a labor task. The major

\triangleright Disadvantages drawback of this model is the this model is that each turn is the two states of the two states as a state of the

- \checkmark Screening current flows along the edges of REBCO tapes. Hence, it would be overestimated. ϵ Disadvantages
As shown in fig. 2008 in Fig. 2008 is in the selected of the selection of the selected of to represent and axial current. There is a post-
The overestimated.
- \checkmark Current in the z-direction cannot exist. The current at the end of tape cannot be simulated correctly.

Single panckae coil

Every turn is not connected with each other. It looks multipe concentric rings.

II. FEM + Thin film approximation *^q*d*^v* ⁼ *^R*sc ⁺ *^R*stabilizer [∂]*^I* ⁼ [∂]*^R* ∂*V* [∂]*^I* ⁼ *^R* ¹ # *^q*d*^v* ⁼ *^R*sc ⁺ *^R*stabilizer

*I*2

∂

! 1

^θ + *R*c(*I*op − *I*θ)

∂*A* " $\overline{}$

∂

 \overline{a}

!!
!!
!

∂*A*

 $\frac{1}{\sqrt{2}}$

∂

Features

- \triangleright Hard to implement a code
- \triangleright Long computation time and large memory usage
	- \checkmark To improve them, a special technique (e.g., fast multipole method) is used.
- \triangleright Considering the pancake-winding structure and the axial current
- Ignoring the electrical field induced by the time-varying axial magnetic field

of quench protection is also discussed.

[∂]*^t* ⁺ *^J*op"

respectively. The coil inductance *L* is easily computed by a

Issue

\triangleright What happens, when the *z* component of inductance term is neglected?

Thin film approximation (TFA) assumes (1) very thin film, (2) uniform phenomenon in the thickness direction, and (3) no enforced current. Due to (3), the enforced current flows along the film edges, like the Bean model. According to the Norris's paper [2], that is wrong.

- \checkmark Homogeneous into thin direction due to infinite length
- \checkmark Operating current flows along the edge of REBCO tape

- ü Finite thickness
- Operating current flows uniformly in REBCO tape (*v* component of field must be considered)

[2] W. T. Norris, "Calculation oh hysteresis losses in hard superconductors carrying ac: isolated conductors and edges of thin sheets, *Journal of Physics D: Applied Physics*, 3, 489-507, 1969.

III. Simple equivalent circuit [∂]*^I* = (*ⁿ* [−] 1)*^l* (4) *S^e III. Simple equiva ^NiBe*d*S^e* ⁼ [−]1(*i*+1) *^B*¹ [−] *^B*² ⁺ *^B*³ [−] *^B*⁴ equivaler *^NiBe*d*S^e* ⁼ [−]1(*i*+1) *^B*¹ [−] *^B*² ⁺ *^B*³ [−] *^B*⁴

(5)

*R*sc*I*sc = *R*mt*I*mt (19) *R*sc*I*sc = *R*mt*I*mt (19) *R*sc*I*sc = *R*mt*I*mt (19)

REBCO coils
\n
$$
L\frac{dI_{\theta}}{dt} + M\frac{dI_{sc}}{dt} + \frac{R_{re}R_{st}}{R_{re} + R_{st}}I_{\theta} = R_{ct}(I_{t} - I_{\theta})
$$
\n
$$
I_{\theta} = I_{re} + I_{st}
$$
\n
$$
R_{re}I_{re} = R_{st}I_{st}
$$
\n
$$
L\frac{dI_{sc}}{dt} + M\frac{dI_{\theta}}{dt} = R_{sc}I_{sc}
$$
\n
$$
L\frac{dI_{sc}}{dt} + M\frac{dI_{\theta}}{dt} = R_{sc}I_{sc}
$$

I^θ = *I*sc + *I*mt (18)

*R*sc*I*sc = *R*mt*I*mt (19)

Features [∂]*^r* (*rA*) .
១[។] −−
−− .
פי σ **Fea** \overline{a}

! *E*

Ic

" 1

- Ø Easiest [∂]*^t* ⁺ *^J*op" $\overline{}$ **∂** + *Z* + \pm
	-
	- → Simple RL parallel circuit method
→ Short computation time and small memory usage
- > Simple RL parallel circuit method
> Short computation time and small memory usage
> Not considering the pancake-winding structure and the axial current \triangleright Not considering the pancake-winding structure and the axial current s unu smun momory usuge
realis which at structure and the avial arrivent α inductually sullecture and the axide current $\frac{1}{2}$ distribution $\frac{1}{2}$, the partial element equivalent equivalent explicit e \bf{P} , we can be also considered in the distribution \bf{P} and \bf{P} and \bf{P} **offer the computation time and sman memory usage
Not considering the pancake-winding structure and the ax** distributed network model and the partial element energy $\frac{1}{2}$ **∂** comparation time and sinan memory usage
considering the pancake-winding structure and the axial the coil is the compact the turn-to-turn contact respectively.

IV. Complicated network equivalent circuit [∂]*^I* = (*ⁿ* [−] 1)*^l I*2 *c Ic* ica*ve*a nevwork equivalent circuit [∂]*^I* = (*ⁿ* [−] 1)*^l I*2 *c Ic* . Complicated network equivalent circuit \overline{a} [∂]*^I* = (*ⁿ* [−] 1)*^l I*2 *c Ic* . Complica*ve*a nevwork equivalent circult \overline{a} $\frac{1}{2}$ *<u>r* $\frac{1}{2}$ *<i>n* $\frac{1}{2}$ *n* $\frac{$ *d* dent circuit *R*re + *R*st *Jc E^c Jc E^c va* veα πο al*ent circuit P*omplicated network equivalent circuit∧. *^L*d*I*^θ ^d*^t* ⁺ *^M* ^d*Isc* ^d*^t* ⁺ *R*re + *R*st *I*^θ = *R*ct(*I*^t − *I*θ) (20) mplicated network equivalent circuit d α α α α α α *I*^θ = *R*ct(*I*^t − *I*θ) (20) *I*B \sim *I*_B \sim *I*_B *<u>R ted network equivors*</u> *I*^θ = *I*re + *I*st (21)

IV. Complicated network equivalent circuit

\triangleright Acceleration and downsizing

 \checkmark The inductance is a function of 1/R. The mutual inductance slightly changes with distance. The mutual inductance at arbitrary points of a pancake coil from arbitrary points of the other pancake coils does not largely change. Eventually, it is possible to use the mutual inductance at arbitrary points of a pancake coil from a whole pancake coil in the complicated network circuit model. i.e., the screening current can be computed for each individual pancake coil.

V. Simulation Result

V. Simulation Results

Screening current REBCO coil

Stress Simulation Considering Screening Current

Alternatively simulated

Comparing with a simulation without consideration of coil deformation:

- \checkmark By changing the angle of magnetic field to REBCO tape, an accurate screening current can be simulated.
- \checkmark By changing the angle of magnetic field to c-axis, Jc also changes,

Stress Simulation Considering Screening Current

5-turn test coil

A small test coil was charged inside an external magnet.

- \triangleright Test coil was placed 25 cm away from the midplane. *z*
- \triangleright Operation profile is shown bellow.
- \triangleright Screening current and elastic simulation were done. \vert is \vert External

Screening current simulation Stress simulation

r

25 cm

 6 cm

Stress Simulation Considering Screening Current

Current distribution with Field Vectors

With considering deformation

- A few screening current models have been proposed, each model have different features.
	- \checkmark Axisymmetric FEM
	- \checkmark FEM + thin film approximation
	- \checkmark Simple equivalent circuit
	- \checkmark Complicated network equivalent circuit (newly developed)
- Coil deformation must be considered to accurately simulate screening current.
- Benchmarks are needed as soon as possible.

Thank you for listening!

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